PTO/SB/08A (10-01)

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Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 2

Complete if known			
Application Number	10/672,961		
Filing Date	September 26, 2003		
First Named Inventor	Glenn J. Leedy		
Art Unit	2822		
Examiner Name	Monica Lewis		
Attorney Docket Number	ELM/002 Cont. 4		

	U.S. PATENT DOCUMENTS						
	Examiner Cit	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant	
initia	18*	No.1	Number - Kind Code ² (if known)	MM-DD-YYYY	Applicant of Cited Documents	Figures Appear	
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			5,786,629	07/28/1998	Faris ·		
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(use	(use as many sheets as necessary)			Examiner Name	Monica Lewis	
Sheet	2	of	2	Attorney Docket Number	ELM/002 Cont. 4	

		NON PATENT LITERATURE DOCUMENTS	
Examiner initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	7*
M		S. Wolf, Silicon Processing, 1990, Lattice Press, Volume 2, Page 111.	
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INFO	PRMATION	DISC	CLOSURE	Filing Date	September 26, 2003	
STATEMENT BY APPLICANT				First Named Inventor	Glenn J. Leedy	
1			. 2.07	Art Unit	2822	
(use	as many shee	ets as	necessary)	Examiner Name	Monica Lewis	
Sheet	1	of	2	Attorney Docket Number	ELM/002 Cont. 4	

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